



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chun-Keng Hsu

Group Art Unit: 3652

Serial No.: 10/040,104

Examiner: Paul T. Chin

Filed: Oct. 19, 2001

In Response to Office Action
Dated: Dec. 5, 2002

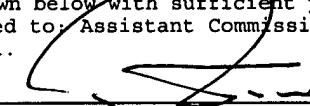
For: WAFER BLADE EQUIPPED WITH PIEZOELECTRIC SENSORS

Attorney Docket No.: 67,200-531

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

Date: March 5, 2003


R.W. TUNG

RECEIVED
MAR 14 2003
RESPONSE TO OFFICE ACTION
GROUP 3600

Assistant Commissioner
for Patents
Washington, D.C. 20231

Dear Sir:

In response to an Office Action mailed December 5, 2002,
please enter the following amendments and consider the following
remarks.